

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Shi, et al.

Title:

SYSTEM AND SOFTWARE FOR DATA COLLECTION AND

PROCESS CONTROL IN SEMICONDUCTOR MANUFACTURING

AND METHOD THEREOF

App. No.:

09/905,220

Filed:

July 12, 2001

Examiner:

Alexander J. Kosowski

Group Art Unit:

2125

Atty. Dkt. No.: 1458.TT4869

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Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

DEC 1 0 2003

Technology Center 2100

AMENDMENT/RESPONSE

Dear Sir:

In response to the Office Action mailed August 27, 2003 regarding the above captioned patent application, the Applicant(s) hereby respectfully submit the following amendment and response.

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to the Commissioner for Patents on

Katrina Prati

Typed or Printed Name

Signature